

Appl. No. 10/677,929  
Amdt. dated 12/29/2004  
Reply to Office Action of 9/29/2004

Attorney Docket No.: N1085-00154  
TSMC 2003-285

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In application of: **Cheng I. Sun**

Examiner: **Alexander J.  
Kosowski**

Serial No.: **10/677,929**

Group Art Unit: **2125**

Filed: **10/02/2003**

Confirmation No.: **9602**

**For: METHOD AND SYSTEM FOR ANALYZING SEMICONDUCTOR FABRICATION**

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Examiner Alexander J. Kosowski  
Mail Stop Non-Fee Amendment  
Commissioner for Patents  
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Date: December 29, 2004

*Maria E. Provencio*

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Examiner Alexander J. Kosowski  
Commissioner for Patents  
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**RESPONSE TO OFFICE ACTION DATED SEPTEMBER 29, 2004**

Sir:

Responsive to the Office Action dated September 29, 2004, please re-examine and reconsider the above-identified patent application according to the amendments and remarks provided.

**Amendments to the Specification** are shown on page 2 of this paper.

**Amendments to the Claims** are reflected in the Listing of Claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.